MICRO- NANO- DEVICES FOR BIO

How to develop a Lab on a chip and a biosensor

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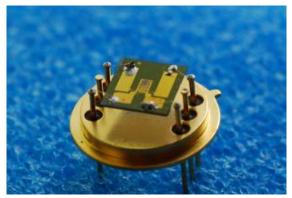










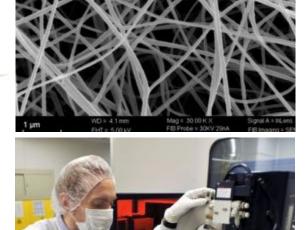




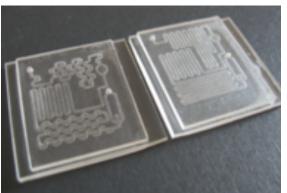
- Fundamental research on materials and processes for micro- and nano-technologies
- Design and fabrication of MEMS and nanostructures
- Technological transfer
- Education



- 7 Professors
- 5 Permanent Researchers
- 16 Fellowships / Post Doc
- 8 PhD students
- 2 Technicians
- 1 Administratives









Outlook

- Motivations
- Microfluidics
- Biosensing
- Development tools & Facilities
- A BAW microfluidic chip
- A nano EGO-FET biosensor



MOTIVATIONS



Motivations: Personalized medicine

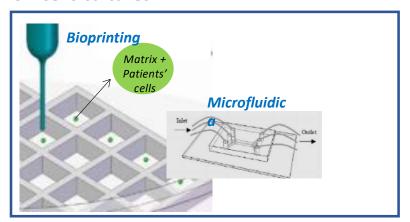
Oncologic diseases

Neurological disorders

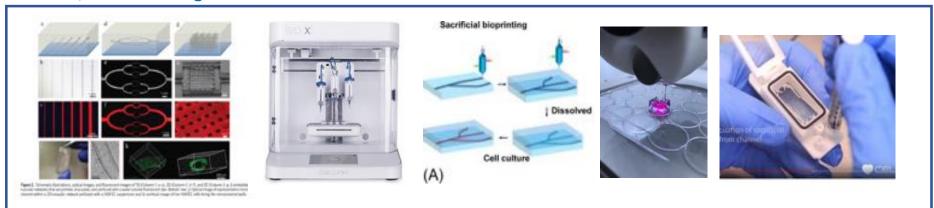
Regenerative medicine



3D cells cultures



Scaffold, Tissues & Organs in silico



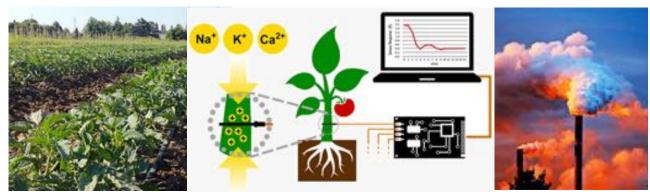


Motivations: health / food / environmental monitoring

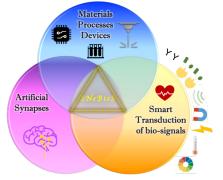


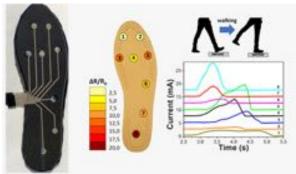


Food monitoring for cotaminants: antibiotics, toxins, chemicals...



Precise Agriculture
Water control
Air control for pollutant





Chronic disease
Nanomedicine
drug delivery
Sport

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Motivations: Liquid Biopsy approach



Bracht et al.; Current Oncology Reports (2018)
Paper on NON-SMALL CELL LUNG CANCER
TEPs and ctDNA have potential in disease monitoring and can indicate acquired resistance much earlier than radiography disease progression

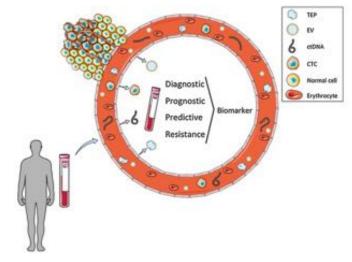
Tool for diagnosis, prognosis, prediction of responce to therapy

- TEPs tumor encapsulated platelets
- ctDNA circulating tumor DNA
- CTCs circulating tumor cells
- EVs extracellular vesicles

Advantages

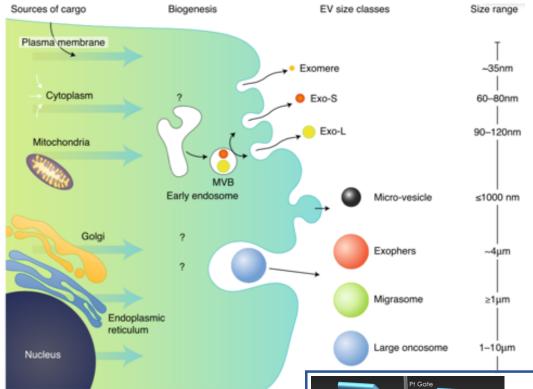
Repeated sampling

Reflectation of the complete molecular status of disease





Motivations: Liquid Biopsy approach



- Exosomes are heterogeneous, nanoscale vesicles that mediate cellular communication
- EV are promoters of cancer progression: 1. transfer of active biomolecules to the tumour environment; 2. functional role of their cargo in sorting disease progression; 3. inhibition of EV secretion or biogenesis correlated with the drug resistance development
- EV heterogeneity is not only defined by variation in size but also by variation in cargo between and within each size class
- Exomeres and exosomes have different biogenesis, different cargo and different biodistribution
- Whereas the biogenesis of exosomes is relatively well defined, biogenesis of larger vesicles and exomeres is currently unknown

Di Vizio Nat. Cell. Biol. 2018

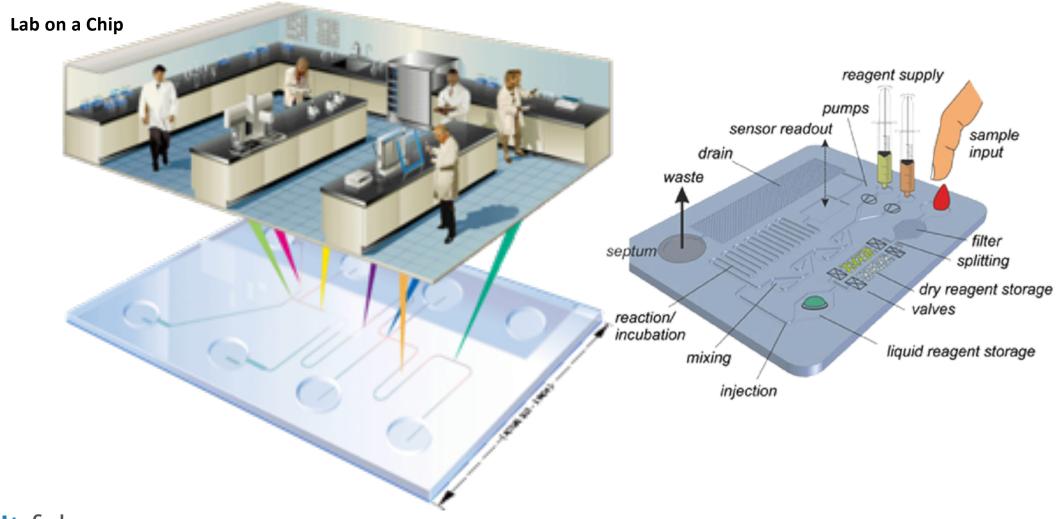
Biomarkers detection on fluidic integrated biosensors

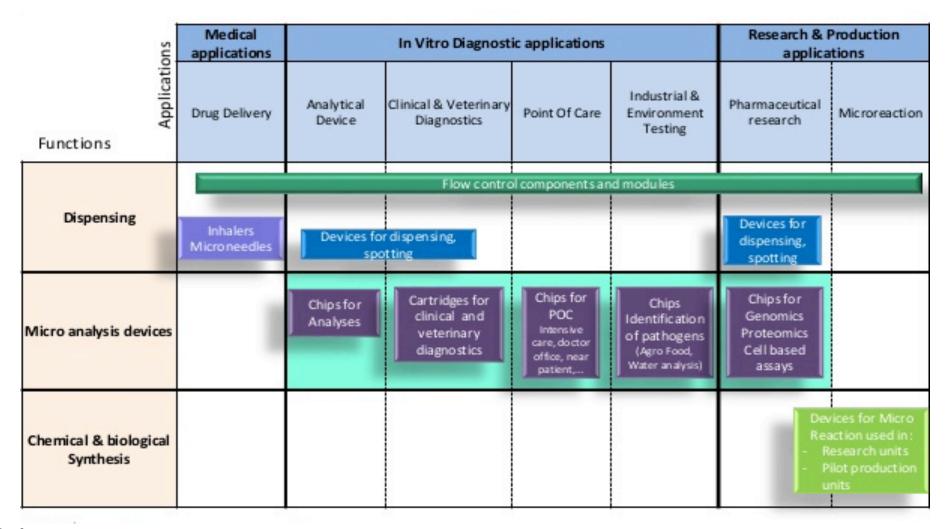




MICROFLUIDICS

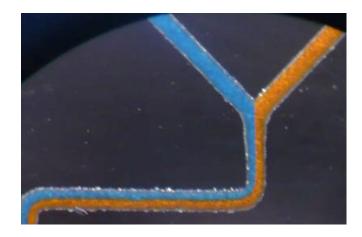


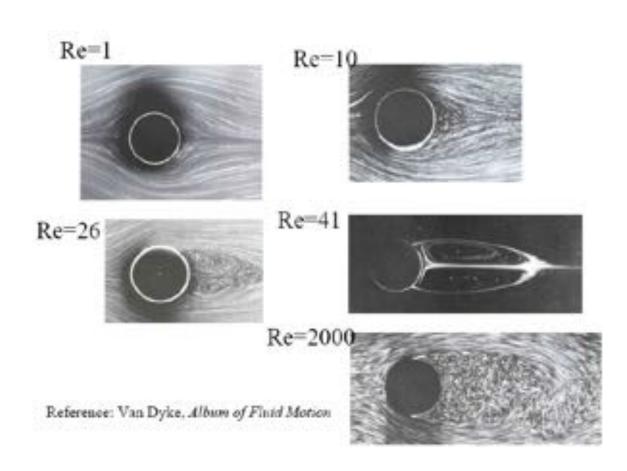






- surface forces are dominant;
- diffusion driven system;
- the flow is in laminar regime;
- viscosity of fluids are important.







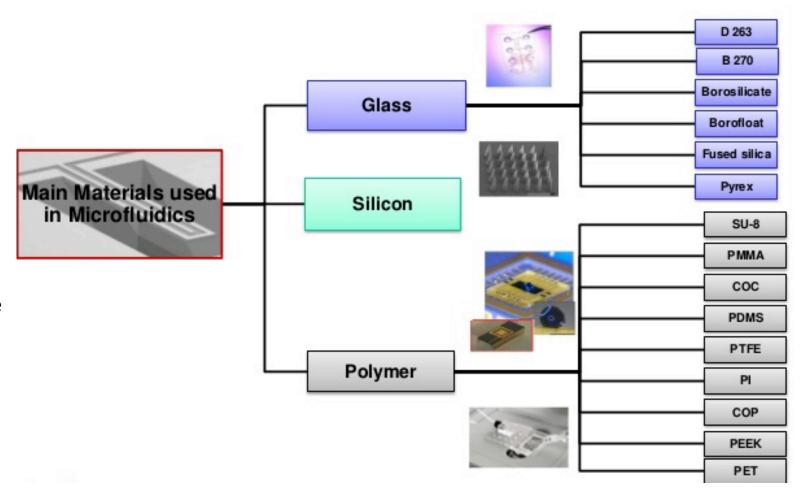
Materials:

Silicon micromachining

- Integrated circuits → Transport electron
- Microfluidics →
 Transport molecules
 and fluids

Plastic micromachining

- Stamp and mold
- Microcutting
- Laser machining
- Microelectro discharge machining
- Laminting

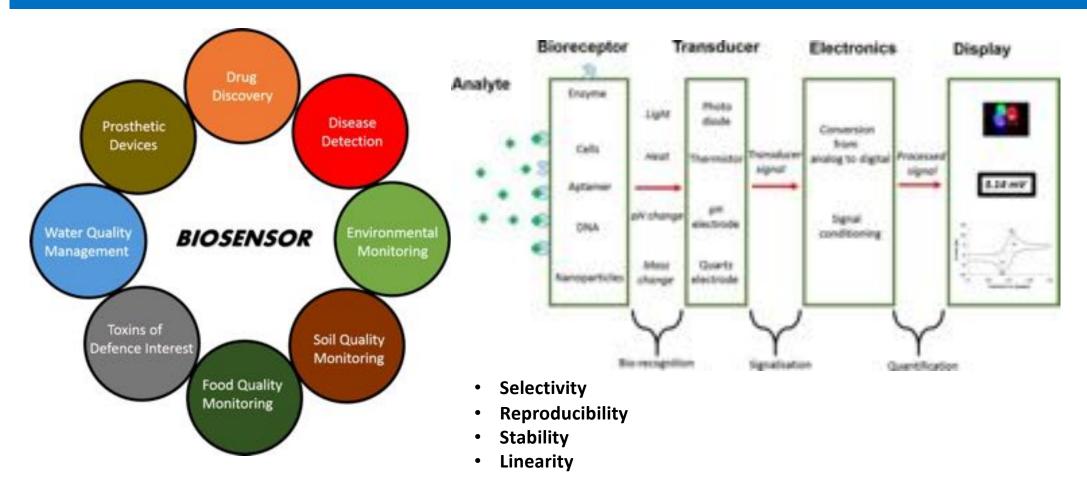




BIOSENSING



Biosensors and Biosensing



Essays Biochem. 2016 Jun 30; 60(1): 1-8.

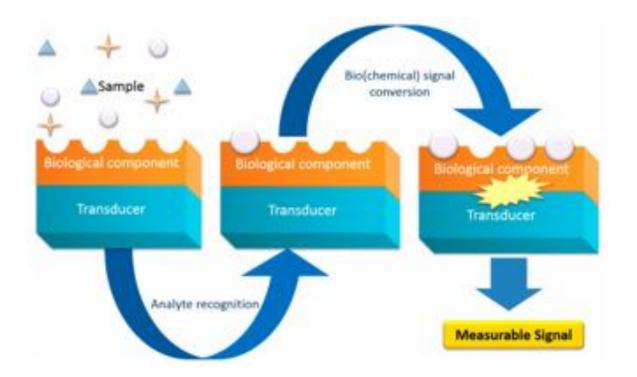


Biosensing basic approach

• Definition of target biomarker Affinity Ab/Ag • Definition of possible reactions for target detection (redox, Biomarker reaction **Target** affinity reaction, etc.) definition • Choose of appropriate device (EGOFET, etc.) Selectivity • Design of bio-interface (surface nanostructuration / Biosensor functionalization / blocking) Sensor Trasduction • Device design Design • Technological processing **Fabrication** • Basic characterizations Measurements Production / • Biodetection experiments integration

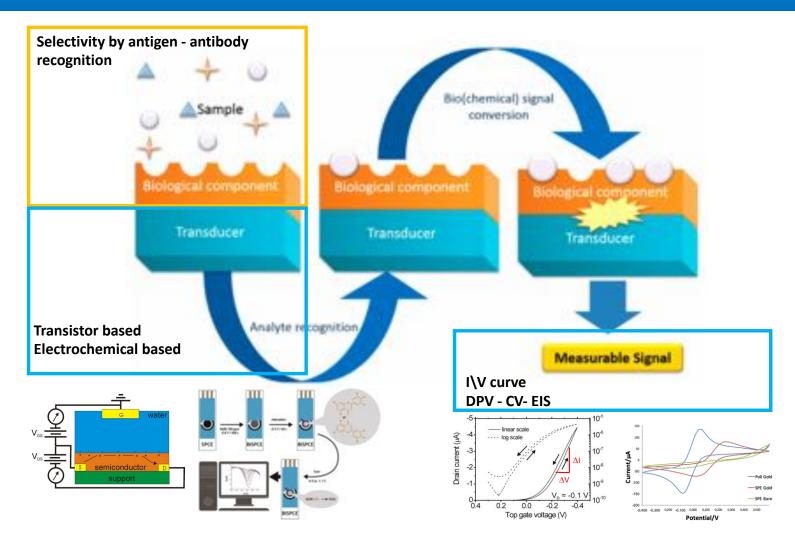


Biosensing





Biosensing





Biosensing

Devices	Technologies		Measurement Setup	Towast	100
	Materials	Processes	/ Tecnhique	Target	L.O.D
Egofet / Gfet	Pentacene or P3HT channel Au or Pt gate	 spin-coating photolithography -CVD -RIE e-beam evaporator Inkjet printing 	source meterprobe stationsyringe pump	TNFα [3]	100 pM
				C-reactive protein [4]	2 pM
				interleukin-4 [14]	5 nM
				DNA and CTCs [15]	0,1pM and 100 cells/μl
Impedance-based µflow	Silicon/Polymer microfluidic device and Au electrodes		potentiostatEIS softwaresyringe pump	cell-derived micropar- ticle (MP) biomarkers [16] , [17]	10 MP/ μL
Micro Electrodes	Porous graphene + metal oxide nanostructures metal electrode + carbon/metal oxide nanostructures	-electrospinning -e-beam evaporation -electrodeposition -CVD -photolitography	- Differential pulse voltammetry (DPV) - Electrochemical Impedance Spectroscopy (EIS) - cyclic voltammetry (CV) - potentiostat	Uric acid [6]	745 nM
Macro Electrodes	Graphene/graphene oxide on GCE or SPE + metal/metal oxide nanostructures	- GO by modified Hummers method - drop casting		DNA hybridization [7]	11 fM
				glucose (enzimeless sensor) [8]	0,01 μΜ
				Uric acid [9]	312 nM
	Laser induced graphene + metal/metal oxide nanostructures	- Laser induced graphene on kapton - electrodeposition		glucose (enzimeless sensor) [10]	250 nM
				thrombin [11]	1 pM (in PBS) 5 pM (in serum)



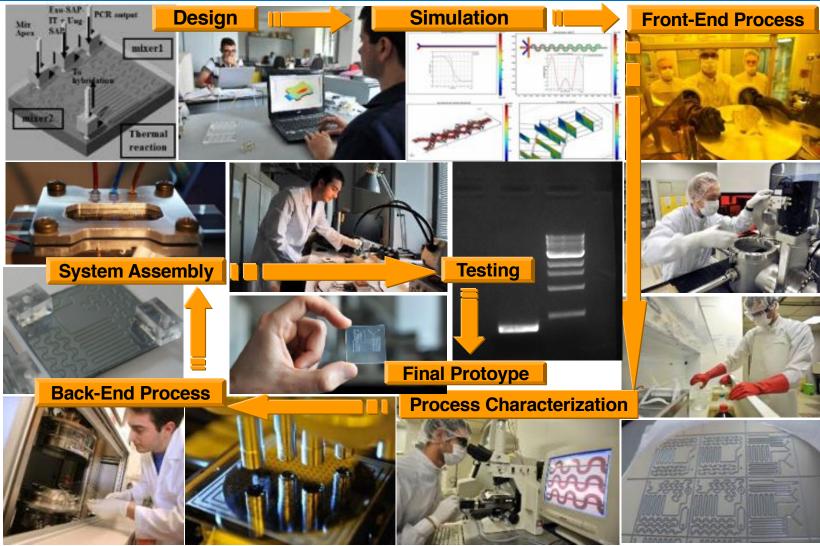
DEVELOPMENT TOOLS & FACILITIES



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How to develop a microsystem: combine expertise, tools and facilities





Computer aid design (CAD)

Main issues:

- vector-based graphics
- Snap functions
- multi layers design
- simple and complex geometries
- use of 2D 3D Cartesian coordinates
- simple function to move or copy object
- Boolean operation



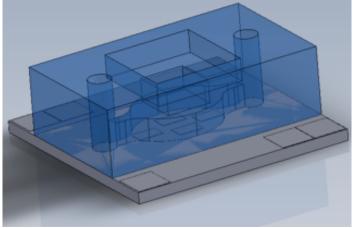








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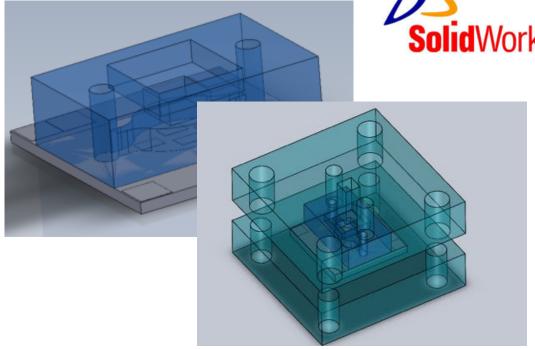








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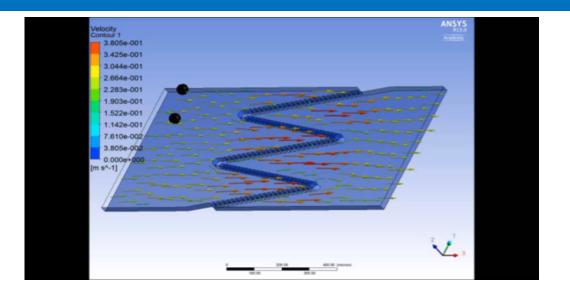


Simulations tools

Finite elements simulation

Main issues:

- a numerical technique
- approximate solutions to boundary value problems for partial differential equations multi layers design
- Discretize and Select the Element Types (1D - 2D – 3D)
- Multiphysics features





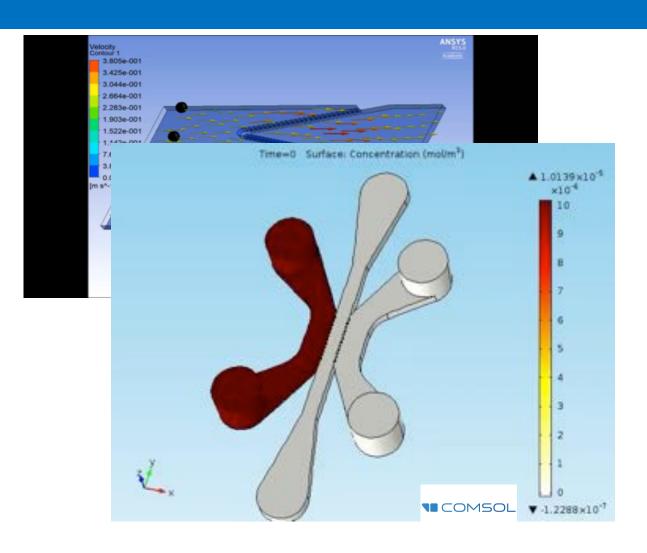


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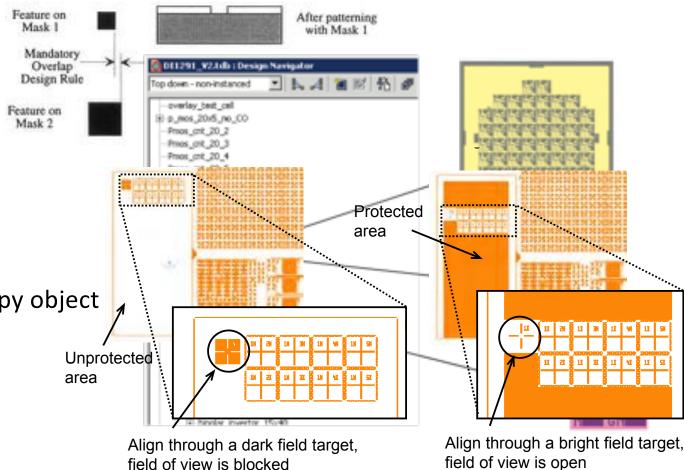


Mask design

Layout editor

Main issues:

- vector-based graphics
- area design rules
- Hierarchical structures
- use of layers and arrays
- Dark / Bright field
- simple function to move or copy object
- Boolean operation





Cleanroom facility

Thin Films growth technologies

- Metal evaporation systems: thermal + electron gun
- Magnetron sputtering
- Plasma Enhanced Chemical Vapor Deposition (PECVD)
- Low Pressure CVD (LPCVD)
- Silicon oxidation
- Rapid Thermal Annealing
- Electroplating
- Graphene CVD

Double-side Optical Lithography

Laser Direct Writing Lithography

Etching:

- Wet
- Dry (plasma, RIE, ICP-DRIE (Bosch® & Cryo))
- Powder Blasting

Polymer machining:

- Hot Embossing
- μ-Stereo Lithography
- μ-Injection Moulding
- Polymer 3D Ink-Jet Printing
- 3D Direct Laser Sintering
- 2 Photon Polymerization (available soon)

Laser Micromachining

Micro Electro-Discharge Machining

Anodic Bonding

Low and Atm. Pressure Plasma Polymerization































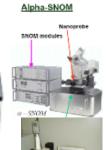


Characterizations facility

Microscopies

Optical FE-SEM + EDX AFM / STM TEM/STEM **Fluorescence**





Spectroscopies

UV-Vis Micro-FTIR Micro Raman XRD XPS







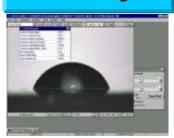


Profilometer



It-fab

Contact Angle



Microfluidic Characterization



characterizations

Electrical & Piezo



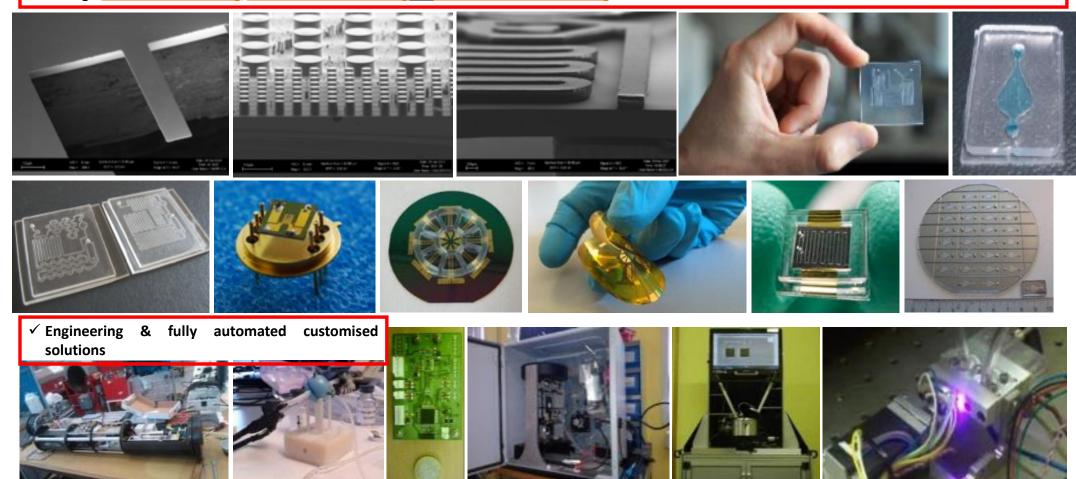


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Process flow development and customized setup

Italian Network for Micro and Nano Fabrication

✓ Set-up of different technological processes and fabrication of MEMS, microfluidics and microstructures (cantilevers, microbridges, membranes, ...) through <u>Bulk Micromachining</u>, <u>Surface Micromachining</u> and <u>LIGA-like Micromachining</u>



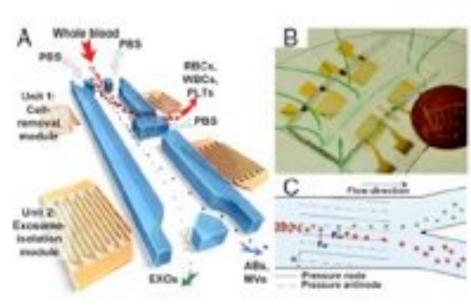
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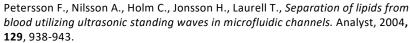
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A BAW MICROFLUIDIC CHIP



State of the art

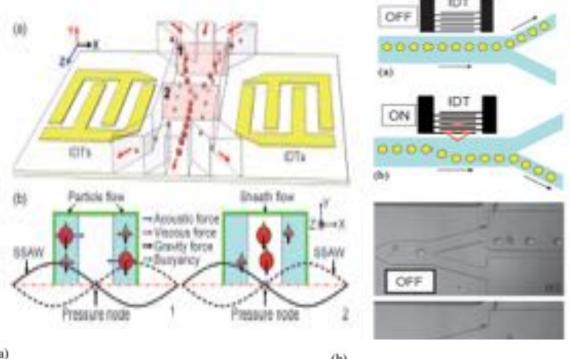




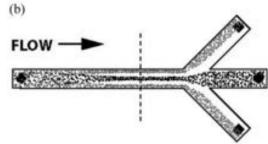
Shi J., Huang H., Strattin Z., Huang Y., Jun Huang T., *Continuous particle* separation in a microfluidic channel via standing surface acoustic waves (SSAW). Lab on a Chip, 2009, **9**, 3354-3359.

Franke T., Abate A. R., Weitz D. A., Wixforth A., *Surface acoustic wave (SAW) directed droplet flow in microfluidics for PDMS devices*. Lab on a Chip, 2009, **9**, 2625-2627.

Wu Mengxi, Ouyang Y., Wang Z., Zhang R., Huang P., Chen C., Li H., Li P., Quinn D., Dao M., Suresh S., Sadovsky Y., Huang T.J., *Isolation of exosomes from whole blood by integrating acoustics and microfluidics. PNAS*, 2017, **14**, 10584-10589.



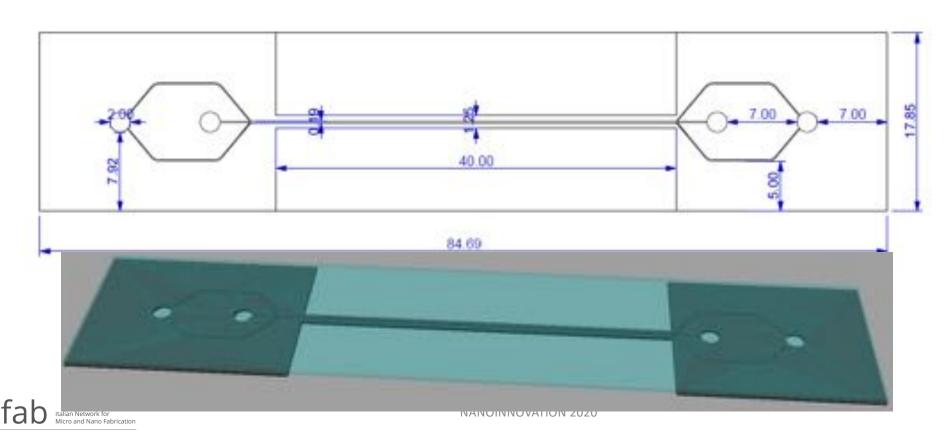




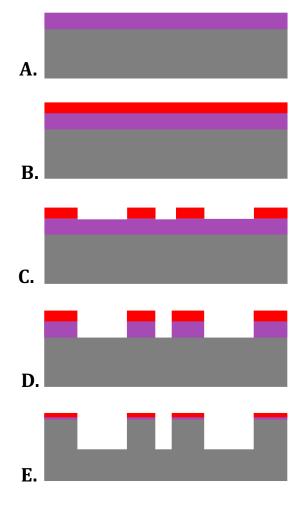


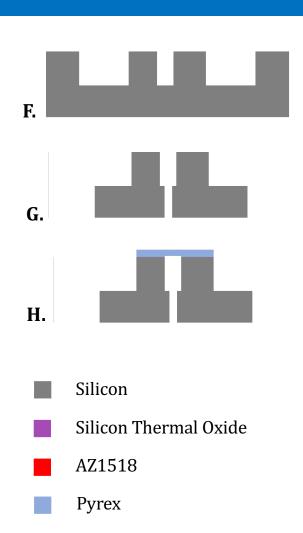
Bulk Acoustic Wave Device design

Frequency [MHz]	W [mm]	Wchannel [μm]	h [μm] with AR = 0.5
4	1.25	190	95



Process Flow





- A. Cleaning
- B. Photoresist Spin Coating
- C. Photoresist Develop
- D. Buffer Oxide Etching
- E. Deep Reactive Ion Etching
- F. Buffer Oxide Etching
- G. Inlet and Outlet Laser Etching
- H. Anodic Bonding

Device Characterization

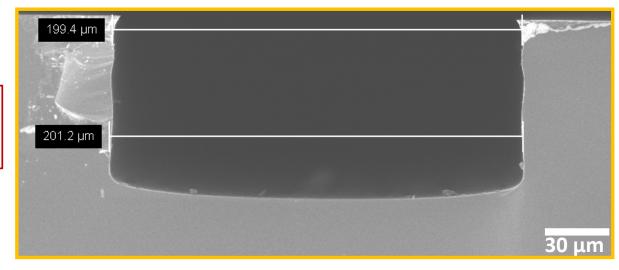
> CAD MEASURE

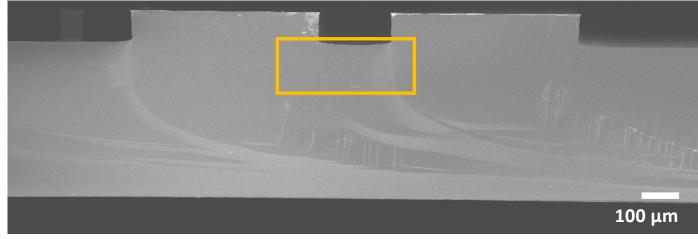
<u>Channel width</u>: 190 μm <u>Channel height:</u> 95 μm

Wall width: 530 μm

> OBTAINED MEASURE

Channel width: 200 μm Channel height: 84,5 μm Wall width: 495 μm





Top: SEM image – zoom cross section

BAW channel

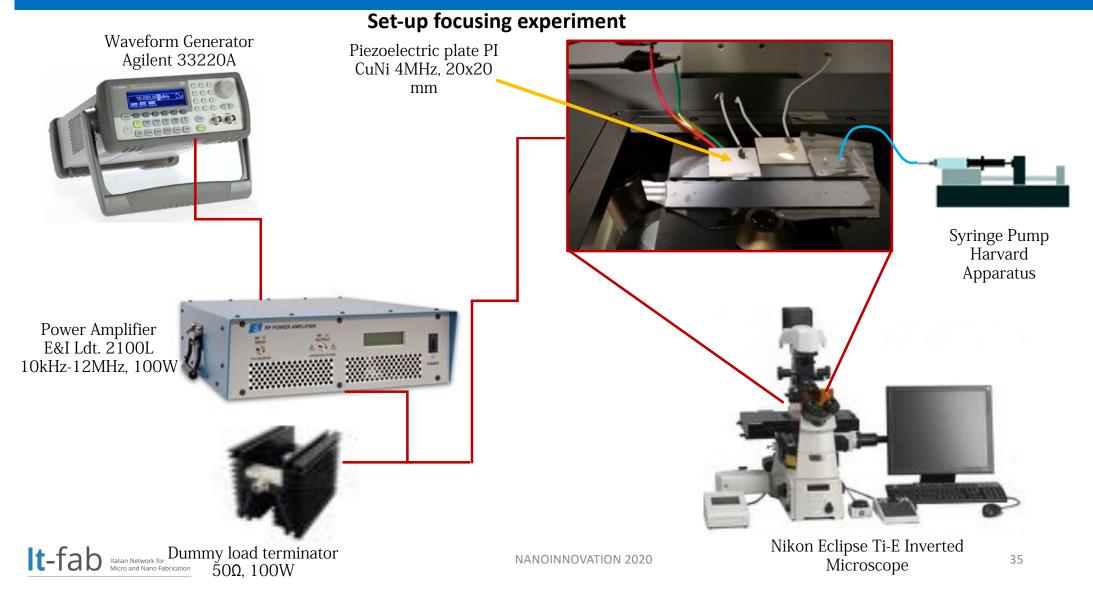
Bottom: SEM image cross section BAW

channel



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Focusing characterization Experiment 1

BAW experiment settings

5.68E+05

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- Constant values: frequency, type of signal, applied voltage, particles
- ➤ Variable values: particles' concentration, flow rate

	Variable values			
Frequency [MHz]	ΔV [V]	Beads' type	Concentrat ion [particles/ mL]	rate
			5.68E+06	1 3 10
4.623	48	4 μm yellow-green fluorescent sulfated	1.41E+06	1 3 10







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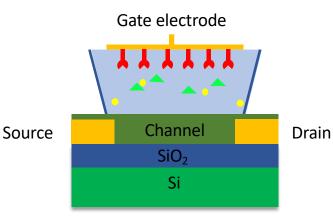
EGO-FET BIOSENSOR

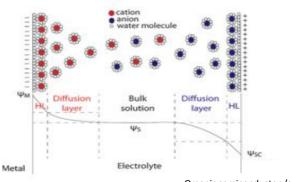
Potential variations in the electrical double layer at gate electrode/electrolyte or channel/electrolyte interfaces shift the threshold voltage of the device, thus modulating the drain current.

$$V_{th} \propto \psi_M, \psi_{SC}$$

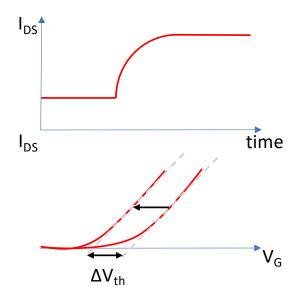
$$I_{ds} = \frac{W}{L} \mu C_{DL} (V_{gs} - V_{th}) V_{ds}$$

 $W = channel \ width$ $L = channel \ length$ $\mu = charge \ carrier \ mobility$ $C_{DL} = electrical \ double \ layer \ capacitance$





Organic semiconductor /graphene

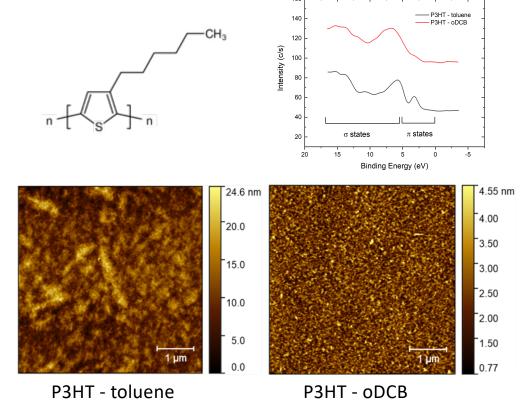




Material: Organic semiconductor

- Poly(3-hexylthiophene-2,5-diyl) (P3HT):
 - high carrier mobility ($\mu \simeq 10^{-1} \frac{cm^2}{V \cdot s}$)
 - Mw = 37kDa
 - regioregularity > 96%.

- Solvent 1,2-dichlorobenzene (oDCB)
 - Boiling point = 180 °C
 - P3HT solubility = 15 mg/ml
 - Favour $\pi \pi^*$ stacking of polymer backbones [2]

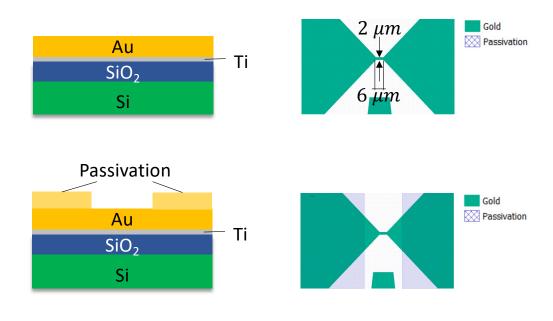


[2] M. Parmeggiani et al., "P3HT Processing Study for In-Liquid EGOFET Biosensors: Effects of the Solvent and the Surface," Sensors, vol. 19, no. 20, p. 4497, Oct. 2019.

t-fab Italian Network for Micro and Nano Fabrication

Device fabrication

- 1. Au microwire fabrication
 - e-beam evaporation Ti/Au (10nm/100nm)
 - UV photolithography
 - Metal etching
- 2. Source/drain electrode passivation
 - Polyimide spin coating
 - UV photolithography
 - Development
- 3. Electromigration by induced break junction



Τi



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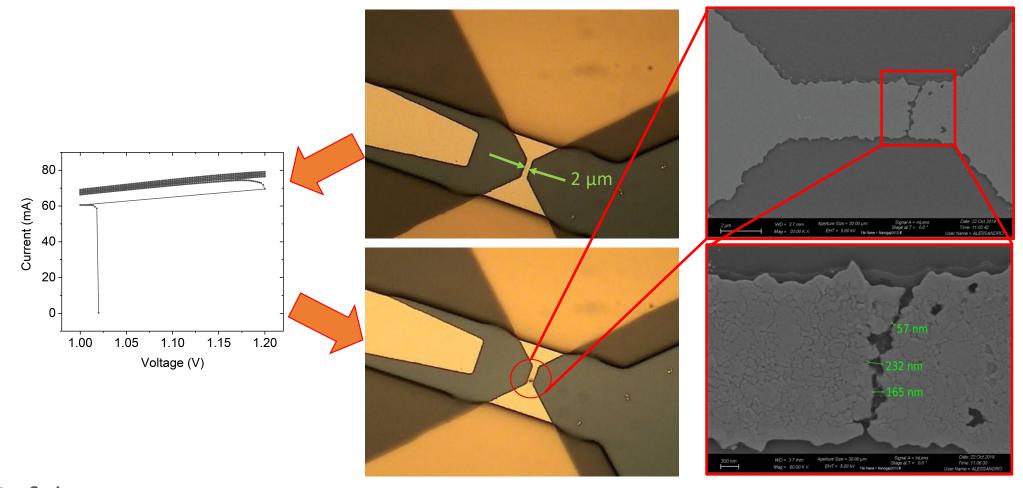
Si

Au

Nanogap, Ti residues may be

present due to adhesion layer

Device fabrication



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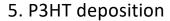
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Device fabrication

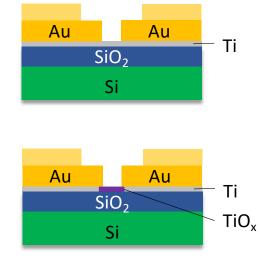
3. Electromigration

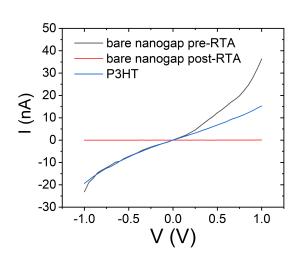
4. Titanum oxidation

 Rapid thermal annealing in O2 at 300 °C for 20 minutes

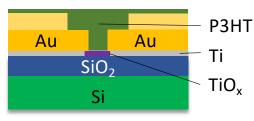


- Spin coating P3HT 2.5mg/ml in oDCB, 2000 rpm for 30 s
- Bake 1h 75 °C under vacuum





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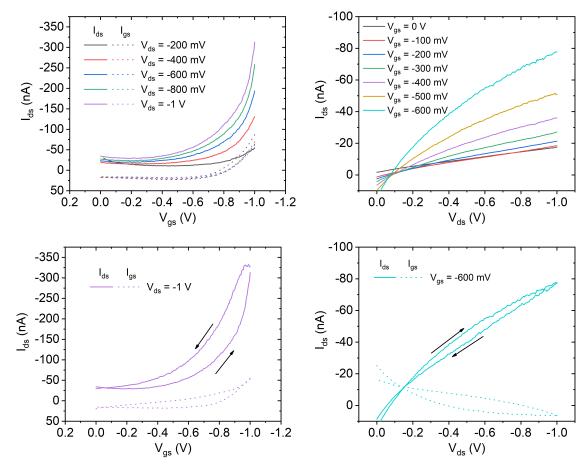




Device characterization



- Transfer and output curves measured in DI H₂O with a leak-free Ag/AgCl electrode
 - Hysteresis most probably due to trap states at P3HT/electrolyte interface
 - high leakage current may be due to small portions of Au electrodes directly exposed to water





CONCLUSION

- Biosensors and LOCs are devices high impact devices
- Micro-nano for bio mostly at research and R&D level
- Development tools & Facilities are fundamental and complex
- Expertise in different field are needed





Thank you for your attention!

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Chilab - Materials and Microsystems Laboratory, DISAT, Politecnico di Torino, Chivasso (Turin), Italy IMEM, c/o Dipartimento di Scienza Applicata e Tecnologia, Politecnico di Torino, Corso Duca degli Abruzzi 24, 10129, Torino

